

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/594,828	<b>Applicant(s)/Patent under Reexamination</b> OPOLKA, RAINER
<b>Examiner</b> Lee Y Quach	<b>Art Unit</b> 2885	

<b>INTERFERENCE SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>